

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	108053	through near3 hole near3 (plate plating)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:12
L2	33962	1 and (sens\$4 detect\$4 transducer measur \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:12
L3	2959	2 and (conductor conducting ) near3 (strip film material sheet layer )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:13
L4	20	3 and (signal\$4) near3 (technology)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:13
L5	230249	bearing.dlm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:15
L6	175	5 and (signal\$4) near3 (technology)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:15
L7	9	6 and (conductor conducting ) near3 (strip film material sheet layer element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:15

L8	16	6 and (conductor conducting conductive) near3 (strip film material sheet layer element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:15
L9	15	8 and (sens\$4 detect\$4 transducer measur \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:15
L10	1	9 and (through) near3 (hole) near3 (plate plating)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:16
L11	1	9 and (through) near3 (hole)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:16
L12	166	73/862.322.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:16
L13	0	12 and (signal\$4) near3 (technology)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:16
L14	15679	(flexible ) near3 (carrier)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:19
L15	232	14 and (through) near3 (hole) near3 (plate plating)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:20

L16	103	15 and (conductor conducting conductive) near3 (strip film material sheet layer element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:20
L17	70	16 and (gage gauge sens\$4 detect\$4 transducer measur \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:20
L18	44	17 and (electronic )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:21
L19	17	18 and (capacitor )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:21
L20	4759	5 and (flexible ) near3 (carrier sheet film layer )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:23
L21	109	20 and (through) near3 (hole) near3 (plate plating)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:24
L22	17	21 and (conductor conducting conductive) near3 (strip film material sheet layer element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:24
L23	10	22 and (gage gauge sens\$4 detect\$4 transducer measur \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:24

L24	2056694	bearing	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:27
L25	739897	24 and (gage gauge sens\$4 detect\$4 transducer measur \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:27
L26	58526	25 and (conductor conducting conductive) near3 (strip film material sheet layer element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:27
L27	23620	26 and (electronic \$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:27
L28	3122	27 and (flexible ) near3 (carrier film sheet layer pad )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:28
L29	108	28 and (through) near3 (hole) near3 (plate plating)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:28
L30	44	29 and (capacitor )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:28
L31	1	30 and (plate) near3 (like) near3 (conductor conductive conducting )	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/28 13:29

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